

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Lin et al.
App. No : 10/815,905
Filed : March 31, 2004
For : INTERFEROMETRIC MODULATION
PIXELS AND MANUFACTURING
METHOD THEREOF
Examiner : Tran, Hoang Q
Art Unit : 2874
Conf # : 9293

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August 29, 2008
(Date)



Jeremy R. Pierce, Reg. No. 59,034

AMENDMENT AND RESPONSE

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Applicants respectfully request consideration of the following Remarks in response to the Office Action sent May 30, 2008 ("Office Action").

A Listing of Claims begins on page 2 of this paper.

Summary of Interview begins on page 6 of this paper.

Remarks begin on page 7 of this paper.